

<b>Notice of References Cited</b>	Application/Control No. 09/895,353	Applicant(s)/Patent Under Reexamination AVERY ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-6,477,434	11-2002	Wewalaarachchi et al.	700/83
	C	US-6,591,242	07-2003	Karp et al.	705/2
	D	US-6,370,582	04-2002	Lim et al.	709/230
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	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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